

Notice of References Cited

Application/Control No.

10/533,420

Applicant(s)/Patent Under
Reexamination
CHEN ET AL.

Examiner

Yelena G. Gakh, Ph.D.

Art Unit

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2002/0048610	04-2002	Cima et al.	424/725
*	B	US-2003/0116497	06-2003	Carlson et al.	210/435
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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